

- 1. SUBSTRATE: Fused Silica
- 2. COATING (APPLY ACROSS COATING APERTURE)
 - S1: Laser Mirror (355nm) R(ABS) >99.80% @ 355nm @ 0-45° AOI
 - DAMAGE THRESHOLD, PULSED: 5 J/cm² @ 355 nm, 20ns, 20Hz

S2: NONE

3. FINE GRIND SURFACE

